

Form PTO 1449  
(Modified)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.  
247051US2XRDSERIAL NO. *14/743,087*  
New Application

## LIST OF REFERENCES CITED BY APPLICANT

APPLICANT  
*Hideto FURUYAMA*FILING DATE  
*Herewith*GROUP  
*1402*

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
<i>F.H.</i>	AO	11-307878	11/05/99	Japan (with English Abstract)		
	AP					
	AQ					
	AR					
	AS					
	AT					
	AU					
	AV					

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

<i>F.H.</i>	AW	Eli Yablonovitch, et al., "Extreme selectivity in the lift-off of epitaxial GaAs films", APPLIED PHYSICS LETTERS, Vol. 51, No. 26, December 28, 1987, Pages 2222-2224				
<i>F.H.</i>	AX	Nan M. Jokerst, et al., "Microsystem Optoelectronic Integration for Mixed Multisignal Systems", IEEE JOURNAL ON SELECTED TOPICS IN QUANTUM ELECTRONICS, Vol. 6, No. 6, November/December 2000, Pages 1231-1239				
	AY					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached

Examiner

Date Considered *3/22/06*

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.